

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination TASHIRO ET AL.	
		Examiner Andy Huynh	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,557,504	09-1996	Siegel et al.	361/773
*	B	US-6,020,634	02-2000	Gerber et al.	257/726
	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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